



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q80433

Makoto MOMOTA, et al.

Appln. No.: 10/802,808

Group Art Unit: 1752

Confirmation No.: 5096

Examiner: Yvette C. Thornton

Filed: March 18, 2004

For: POSITIVE RESIST COMPOSITION AND PATTERN FORMATION METHOD USING
THE SAME

RESPONSE UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 23, 2005, please consider the remarks as submitted herewith on the accompanying pages. A Petition and payment for a one month extension of time are being filed herewith, making this Response due on or before Monday, April 24, 2006.

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